APR 3.0 2007

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PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States. Postal Service as first-class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

April 25, 2007

Date

Alexandra Beggs

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jason B. Elledge

Attorney Docket No.: 500188.03

Patent No. : US 6,932,672 B2

Serial No.

: 09/833,029

Issue Date: August 23, 2005

Filed

: April 10, 2001

Title

: APPARATUS FOR IN-SITU OPTICAL ENDPOINTING ON WEB-FORMAT

PLANARIZING MACHINES IN MECHANICAL OR CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE SUBSTRATE ASSEMBLIES

AND METHODS FOR MAKING AND USING SAME

REQUEST FOR CERTIFICATE OF CORRECTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Certificate

MAY 0 2 2007

Of Correction

A Certificate of Correction under 35 U.S.C. § 254 is respectfully requested for the above-identified patent in order to correct Patent and Trademark Office errors made during the printing of the patent. The changes in the patent needed to correct the errors are as follows:

| Column, Line | Reads | Should Read |
|---------------------|-------------------------|-----------------------|
| Column 5, Line 4 | "interferrometer" | interferometer |
| Column 7, Line 32 | "system in defined" | system is defined |
| Column 8, Line 30 | "and a under surface," | and an under surface, |
| Column 9, Lines 63- | "a planarizing at zone" | a planarizing zone |

Column 9, Line 65

"a light source under to the

--a light source under the table--

table"

Column 10, Line 24

"and a under surface,"

--and an under surface,--

Column 11, Lines 6-

"a planarizing at zone at least

--a planarizing zone at least

7

within"

within--

The above errors for which correction is requested under 35 U.S.C. § 254 were made in the printing of the patent or in the application. The errors are considered sufficiently important to justify the processing of a Certificate of Correction under 35 U.S.C. § 254. A Form PTO-1050, in duplicate, is enclosed herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication to Deposit Account No. 50-1266. A duplicate copy of this sheet is enclosed.

Favorable consideration of this Request is respectfully requested.

Respectfully submitted,

Date: Upil 24, 2007

 $\mathbf{R}_{\mathbf{V}}$

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(206) 903-8785

Attorney for Applicant(s)

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Enclosures:

Postcard

Form PTO-1050 (+ copy)

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UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO.

US 6,932,672 B2

DATED

August 23, 2005

INVENTOR(S)

Jason B. Elledge

It is certified that errors appear in the above identified patent and that said Letters Patent is hereby corrected as shown below:

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| Column 9, Lines 63-64 | "a planarizing at zone" | a planarizing zone |
| Column 9, Line 65 | "a light source under to the table" | a light source under the table |
| Column 10, Line 24 | "and a under surface," | and an under surface, |
| Column 11, Lines 6-7 | "a planarizing at zone at least within" | a planarizing zone at least within |

MAILING ADDRESS OF SENDER:

DORSEY & WHITNEY LLP 1420 Fifth Avenue, Suite 3400 Seattle, Washington 98101 Patent No. <u>US 6,932,672 B2</u>

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FORM PTO-1050 (REV. 3-82)

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